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No. of Printed Pages:2

## SARDAR PATEL UNIVERSITY

M.Sc. (PHYSICS) (IV Semester) Examination Tuesday, 12<sup>th</sup> April, 2016 2:30 pm to 5:30 pm Course No.: PS04EPHY04 ADVANCED SOLID STATE ELECTRONIC DEVICES

Total Marks: 70

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Q.1	Eight multiple choice questions (MCQ) carrying one mark each.	(8)
(i)	The band gap shrinkage in Si npn transistor with emitter doping of 10 <sup>18</sup> cm <sup>-3</sup> at room temperature (300K) is  (a) 0.022 eV  (b) 0.225eV  (c) 2.2 eV  (d) None	
(ii)	Which of the following semiconductor is useful to make monolithic opto- electronic integrated circuits (OEIC)?  (a) Ge (b) Si (c) GaAs (d) CdTe	
(iii)	For which of the following devices, the channel conductivity is highest? (a) JFET (b) MESFET (c) MODFET (d) MOSFET	
(iv)	MOS capacitor is different from discrete parallel plate capacitor as,  (a) Its capacitance can be varied by varying gate voltage.  (b) Its capacitance is purely a function of oxide thickness.  (c) It is a fixed value three terminal capacitance.  (d) None of the above.	
(v)	Which of the following devices depends for its operation on delta doping?  (a) JFET (b) MODFET (c) MESFET (d) MOSFET	
(vi)	Which of the following is a most power efficient device?  (a) JFET (b) MODFET (c) MESFET (d) CMOS	
vii)	Which of the following devices is a no gain high speed photodetector?  (a) APD (b) P-I-N (c) photoconductive (d) None	
viii)	At cut-off wavelength, the absorption coefficient of semiconductor is $(a) \infty$ $(b) 2$ $(c) 0$ $(d) 1$	
(i) (ii) (iii) (iii) (iv)	(attempt any seven out of nine). What is band gap shrinkage? Explain. Discuss advances in Si based HBTs. Write differences between JFET and MESFET.	(14) (70)
(**)	(r)	. 0)



(v) (vi)	Write down the important issues of short channel MOSFET.  Sketch the energy band diagram of MOS capacitor in inversion region and	
(****)	discuss why it is called so.	
(vii)	Write the advantages and limitations of Avalanche photodetector.	
(viii)	Discuss Light-Current characteristics of LED.	
(ix)	Discuss different materials used for construction of Light Emitting Devices.	
Q.3(a)	Explain how channel length is modulated in FETs.	(6)
(b)	Discuss the need for band tailoring and its methods on the basis of BJT design limitations.	(6)
	OR	
(b)	Discuss how the active channel in case of MESFET is isolated from the gate and derive an expression for drain current in terms of material parameters.	(6)
Q.4(a)	Discuss the structure and characteristics of SIMOX.	(6)
(b)	Describe key motivations of GaAs/AlGaAs MODFET using schematic and energy band profile diagrams.	(6)
	OR	
(b)	With the help of charge control model of MODFET derive expression for the 2-D electron gas density $n_s$ introduced in the spacer region of a MODFET.	(6)
Q.5(a)	Distinguish between depletion and enhancement MOSFETs.	(6)
(b)	Discuss in detail about the MOS capacitor and its C-V Characteristics	(6) (6)
(~)	OR	(0)
(b)	Discuss important effects in long channel MOS devices.	(6)
0.6(a)	Explain the characteristics of DINI Physical Actions and No. 1	
Q.6(a)	Explain the characteristics of P-I-N Photodetector and discuss its design issues.	(6)
(b)	Discuss following LED performance issues in detail.	(6)
()	(i) Spectral Purity	(0)
	(ii) Temporal Response.	
	OR	
(b)	Discuss the structure and characteristics of an Edge Emitting LED.	(6)

